

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 2525**  
Tetsuji TOGAWA et al. : Attorney Docket No. 2004\_0624  
Serial No. 10/827,237 : Group Art Unit 1765  
Filed April 20, 2004 : Examiner Patricia Ann George

APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed November 2, 2005, please amend the above-identified application as follows: